

Continuous Emissions Monitoring and Process Control

Glass Manufacturing Industries



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Process control and emissions monitoring in a glass manufacturing plant can be a challenge due to high temperature in the flue gas. To use an extractive system in this environment will demand a lot of maintenance.

The OPSIS DOAS system provides the glass industry with an accurate analyser that will operate with a minimum of maintenance. The OPSIS DOAS system is based on a non-contact method that uses an optical path to measure across the duct.

The light is transported in an optical fibre to the analyser, and one unit can operate several measurement paths.

A single OPSIS system will measure all relevant gas components such as NO $_{\rm X}$, SO $_{\rm 2}$, CO, CO $_{\rm 2}$, H $_{\rm 2}$ O, and O $_{\rm 2}$.

RETURN OF INVESTMENT

Many glass manufacturing plants will have to install monitoring systems to meet the environmental requirements.

The cost of investing in an OPSIS system is small compared to the amount of money that is spent on maintaining extractive measuring systems.

TEST AND APPROVALS

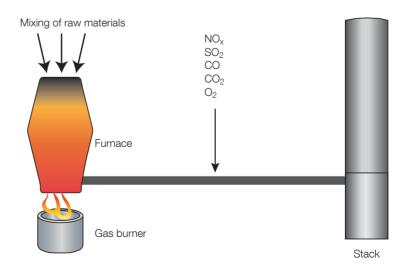
The OPSIS system has been tested and approved by a number of internationally recognized institutes and authorities. The system is approved by German TÜV and British MCERTS among others. Full details are available on request.

OPSIS PRODUCT PORTFOLIO

OPSIS has a full product portfolio for measurement of gases. It includes complete CEM systems designed to meet the European directives, TDL systems, O_2 analysers, and Hg analysers.

For further information, please visit www.opsis.se.

QAL 1 CERTIFICATION:
BEST PERFORMANCE
LONGEST CALIBRATION INTERVAL

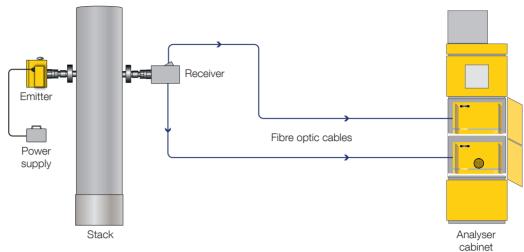


The measurement is made by a cross-stack optical sensor. The system can operate in high dust load and high temperature.



SYSTEM OVERVIEW

An OPSIS system layout for emissions monitoring and process control in a glass manufacturing industry



PERFORMANCE DATA

(typical data which may vary depending on application)

Compound	Max. measurement range (1 m path) ⁽¹⁾	Lowest measurement range according to EN 15267	Min. detectable quantities (monitoring path 1 m, measurement time 30 sec.)	Accuracy Better than 2% of measured value or equal to the detection limit (whichever is greater).
UV/IR DOAS Analyser Models AR600 / AR602Z / AR602Z/Hg / AR602Z/N / AR602Z/NHg / AR620				Span drift
NO ⁽²⁾	0–2000 mg/m ³	0-150 mg/m ³	0.5 mg/m ³	Less than 2% per year. Please, refer to QAL1 documents. Zero drift Less than 2% of measurement range per year. Please, refer to QAL1 documents.
NO ₂	0–100% Vol.	0–20 mg/m ³	0.5 mg/m ³	
SO ₂	0-100% Vol.	0–75 mg/m ³	0.5 mg/m ³	
NH ₃ ⁽³⁾	0–1000 mg/m ³	0-10 mg/m ³	0.5 mg/m ³	
Hg ^o	0–1000 μg/m³	0–45 μg/m³	0.5 μg/m ³	
THg	0–1000 μg/m³	0–45 μg/m³	0.5 μg/m ³	
H ₂ O	0-100% Vol.	0-30% Vol.	0.1% Vol.	
HCI	0-10000 mg/m ³	0-1000 mg/m ³⁽⁶⁾	10 mg/m ³⁽⁴⁾	Linearity error Less than 1% of measurement range.
HF	0-1000 mg/m ³	0-100 mg/m ³⁽⁶⁾	5 mg/m ³	
CO ₂	0-100% Vol.	0-30% Vol.	0.5% Vol.	
Benzene	0-1000 mg/m ³	0-20 mg/m ³⁽⁶⁾	0.5 mg/m ³	
Formaldehyde	0–2000 mg/m ³	0–20 mg/m ³	1 mg/m³	
FTIR DOAS Analyser	Models AR650 / AR650/N			
HCI	0-100% Vol.	0–15 mg/m ³	0.5 mg/m ³	
CO	0-100% Vol.	0–75 mg/m ³	2 mg/m ³	
H ₂ O	0-100% Vol.	0-30% Vol.	0.1% Vol.	
HF	0-100% Vol.	0-1.5 mg/m ³	0.1 mg/m ³	
NH ₃	0-100% Vol.	0-100 mg/m ³⁽⁶⁾	2 mg/m ³	
N_2O	0-100% Vol.	0-500 mg/m ³	5 mg/m ³⁽⁵⁾	
CH ₄	0-100% Vol.	0–20 mg/m ³	0.5 mg/m ³	
CO ₂	0-100% Vol.	0-20% Vol.	0.1% Vol.	
LD500 Laser Diode G	as Analyser			
HCI	0-100% Vol.	0-15 mg/m ³⁽⁶⁾	0.5 mg/m ³	
CO	0-100% Vol.	0-5% Vol. ⁽⁶⁾	0.1% Vol.	
H ₂ O	0-100% Vol.	0-30% Vol.(6)	0.1% Vol.	
HF	0-100% Vol.	0-1.5 mg/m ³⁽⁶⁾	0.1 mg/m ³	
NH ₃	0-100% Vol.	0–10 mg/m ³⁽⁶⁾	0.5 mg/m ³	
CO ₂	0-100% Vol.	0-30% Vol. ⁽⁶⁾	0.1% Vol.	
O ₂	0-21% Vol.	0-20% Vol.(6)	0.1% Vol.	
CH ₄	0-100% Vol.	0-20 mg/m ³⁽⁶⁾	0.5 mg/m ³	

- ⁽¹⁾ This data refers to a light path of 1 m. For longer paths, the maximum range is proportionally smaller. Products are available to create shorter paths in very wide stacks.
- $^{(2)}$ Maximum SO_2 concentration: 5 g/m 3 x m.
- $^{(3)}$ Maximum SO_2 concentration: 500 mg/m³ x m.
- (4) Monitoring path 5 m, measurement time 30 sec.
 (5) Detection limit of 1 mg/m³ is optional with hardware upgrade.
- (6) Lowest measurement range. • Recommended monitoring path length: 1 to 5 m.
- After wet scrubbers or when particulate concentration averaged over 1 m is higher than 5 g/m³, the monitoring path length may have to be reduced.
- Max. length of fibre optic cable: please refer to product sheets P9 and P16.



FACTORY TESTED SYSTEMS WITH DELIVERY ON TIME.

Continuous Emissions Monitoring and Process Control by OPSIS

Withstands high temperature in the flue gas

Combines the benefits of UV/FTIR DOAS and TDL technology

Best performance according to QAL1 certification

Longest calibration interval according to QAL1 certification

Automatic QAL 3 check as option

No sampling required, non-contact measurement system

Operates with a minimum of maintenance

Low energy consumption

Internationally approved

Thousands of systems installed worldwide

Serviced by highly skilled service network

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Please contact your OPSIS supplier to discuss your particular system requirements, including the compounds you wish to monitor. Separate product and other industrial application sheets are available.

Specifications subject to change without notice.

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